Substitute for form 1449A/PTO (modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Page 1 of 1

Application Number	10/734684		
Filing Date	December 12, 2003		
First Named Inventor	Theiss, Steven D		
Art Unit	1765		
Examiner Name			
Attorney Case Number	58355US002		

	AUCHAY		U.S. Patent	Documents		
Exam. Init.*	Cile No.	Document Number Doc. Number-(Kind Code if Known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns Relevant Passag Figures A	es or Relevant
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			OTHER DO	CUMENTS	·	
Exam. Init.*	Cite No.	Include name of the author (in CAPITAl journal, serial, symposium, catalog, etc	L LETTERS), title of the	article (when appropriate), title of the item (boo	ok, magazine, y where published	Translation (Check if yes)
20	C1	S.M. Sze, Physics of Semiconductor Devices, 2 nd Ed., John Wiley and Sons, p. 492, New York (1981)				
	C2	NIST Special Publication 922 "Polycyclic Aromatic Hydrocarbon Structure Index," U.S. Govt. Printing Office, by Sander & Wise (1997)				
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*Examiner:	8cl	Date Considered:	19/11/05				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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Page 1 of 1

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Theiss, Steven D		
1765		
DEO, Duy Vu Nguyen		
58355US002		

Document Number Number-(Kind Code (f Known)	Publication Data or Issue Data Issue Data MM-DD-YYYY	Name of Patantine or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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	B2						
	B 3						
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RQ	C1	KIM et al., "Fabrication and Application of a Full Wafer Size Micro/Nanostencil for Multiple Length-Scale Patterning", Microelectronic Engineering, (2003), pp. 609-614, Vol. 67-68	(Check if yes)				
	C2		<u> </u>				
	C3						

*Examiner:	te	Date Considered:	10/	11/05	
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